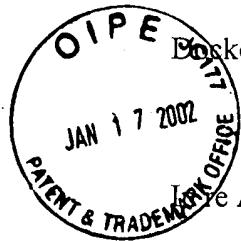


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Patent No.: 61282-017

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the Application of

Kenji SHIMAZAKI, et al.

Serial No.: 09/993,595 Group Art Unit: 2858

Filed: November 27, 2001 Examiner:

For: METHOD AND APPARATUS FOR ANALYZING ELECTROMAGNETIC
INTERFERENCE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

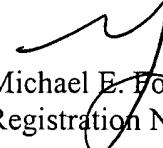
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09/993,595

The relevance of each non-English language reference, and "EMI-Noise Analysis...", is discussed in the present specification.

Respectfully submitted,

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INFORMATION DISCLOSURE
CITATION IN AN
APPLICATION



(PTO-1449)

ATTY. DOCKET NO.
61282-017SERIAL NO.
09/993,595APPLICANT
Kenji SHIMAZAKI, et al.FILING DATE
November 27, 2001 GROUP
2858

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DATE CONSIDERED